

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	2	"20020086164"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/08 07:13
L33	10	"6316110"	USPAT	OR	OFF	2008/07/08 07:35
L34	1	"10562121"	US-PGPUB; USPAT	OR	OFF	2008/07/08 08:37
L35	70	(ZnO or (zinc adj oxide \$2)) same (increas\$4 adj crystal\$8)	US-PGPUB; USPAT	OR	OFF	2008/07/08 08:38
L36	1	"20020086164"	US-PGPUB; USPAT	OR	OFF	2008/07/08 09:30
L37	1	"20020139772"	US-PGPUB; USPAT	OR	OFF	2008/07/08 09:30
S1	10066306	(substrate\$2 or base\$2)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/04/16 12:56
S2	324224	S1 and (dielectric\$2 same (coat\$5 or film\$2 or layer \$5))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/04/16 12:56
S3	73348	S2 and (sputter\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/04/16 12:57
S4	18646	S2 and ((sputter\$4) same ((nitrogen or N) or (oxygen or "O.sub.2")))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/04/16 12:57
S5	18353	S2 and ((sputter\$4) same ((nitrogen or N) or (oxygen or O)))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/04/16 12:58
S6	3190	S5 and (ion\$2 same beam \$2)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/04/16 12:58
S7	94	S6 and ((dielectric\$2 same (coat\$5 or film\$2 or layer\$5)) same crystallize \$2)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/04/16 12:59
S8	37	S7 and @PY< "2004"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/04/16 13:00
S9	6	"5814392"	USPAT	OR	OFF	2008/04/17 08:00
S10	14	"5877555"	USPAT	OR	OFF	2008/04/17 08:08
S11	11	"5960251"	USPAT	OR	OFF	2008/04/17 08:10

S12	23	"5548475"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 07:34
S13	233	((dielectric\$2) same (ion adj beam)) same (crystal \$9)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 07:46
S14	116	S13 and @PY<"2004"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 07:47
S15	1	"10562121"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 09:16
S16	2	"20050209084"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 10:19
S17	284338	(substrate\$2) and (dielectric same (layer\$4 or coat\$5 or film\$2))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 14:56
S18	20986	S17 and ((zinc same oxide \$2) or ZnO)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 14:58
S19	8719	S18 and (SiN or (silicon adj nitride\$2))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 14:59
S20	7030	S19 and (semiconductor \$2 or transistor\$2)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 14:59
S21	1336	S20 and (crystallinit\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 15:00
S22	907	S21 and ((silver or Ag) same (layer\$4 or film\$2 or coat\$5))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 15:01
S23	255	S22 and (alternat\$4 same (layer\$4 or film\$2 or coat \$5))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 15:01
S24	5	S23 and glazing	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 15:01
S25	3754	S20 and (((silver or Ag) same (layer\$4 or film\$2 or coat\$5)))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 15:06
S26	1368	S25 and (alternat\$4 same (layer\$4 or film\$2 or coat \$5))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 15:06
S27	28	S26 and glazing\$2	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 15:06
S28	200	S23 and (surface same resist\$6)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 15:10

S29	10238	(substrate\$2 or base\$2) and ((znO or (zinc same oxide\$2)) same (coat\$5 or layer\$5 or film\$2)) and capacitor\$2	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:29
S30	1078	S29 and (refractive adj index\$3)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:29
S31	37	S30 and (thin same film). ti.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:30
S32	22	S31 and (SiN or (silicon adj nitride\$2))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:35
S33	2	S32 and crystalline	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:35
S34	2	S32 and crystallin\$6	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:35
S35	21	S32 and crystal\$10	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:36
S36	17236	(substrate\$2 or base\$2) and ((znO or (zinc same oxide\$2)) same (coat\$5 or layer\$5 or film\$2)) and (capacitor\$2 or transistor \$2)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:44
S37	14874	S36 and ((ZnO or (zinc adj oxide\$2)) same (layer \$5 or coat\$5 or film\$2))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:45
S38	1714	S37 and (thin same film). ti.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:45
S39	1076	S38 and ((SiN or (silicon adj nitride\$2)) same (film \$2 or coat\$5 or layer\$5))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:46
S40	0	S39 and (refract same (index\$2 or indic\$3))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:46
S41	34	S39 and (refract\$5 same (index\$2 or indic\$3))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:46
S42	55	S38 and (refract\$5 same (index\$3 or indic\$3))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:53
S43	156486	(thin same film\$2).ti.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 07:06

S44	61892	S43 and (capacitor\$2 or semiconductor\$2 or transistor\$2)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 07:06
S45	2775	S44 and ((ZnO or (zinc same oxide\$2)) same (coat\$5 or layer\$5 or film \$2))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 07:07
S46	202	S44 and (((ZnO or (zinc same oxide\$2)) same (coat\$5 or layer\$5 or film \$2)) same ("Si.sub.3.N. sub.4" or (silicon adj nitride\$2)) same (coat\$5 or film\$2 or layer\$5)))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 07:09
S47	41	S46 and @PY<"2004"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 07:09
S48	3	S46 and ((ZnO or (zinc adj oxide\$2)) same (ferroelectric\$2))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 07:28
S49	47	S46 and ((ZnO or (zinc adj oxide\$2)) same (dielectric\$2))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 07:41
S50	3	S46 and ((ZnO or (zinc adj oxide\$2)) same (wave same guide\$2))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 07:53
S51	4	S46 and ((ZnO or (zinc adj oxide\$2)) same (PZT))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 08:00
S52	37038	(substrate\$2) and ((thin adj film\$2) same dielectric \$2)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 08:34
S53	15892	S52 and sputter\$4	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 08:34
S54	10154	S53 and crystal\$10	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 08:34
S55	7729	S54 and (("SiO.sub.2" or silica or (silicon adj \$3oxide\$2)) same (layer \$5 or film\$2 or coat\$5))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 08:35
S56	1171	S55 and ((ZnO or (zinc adj oxide\$2)) same (layer \$5 or film\$2 or coat\$5))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 08:36
S57	670	S56 and ("Si.sub.3.N. sub.4." or (silicon adj nitride\$2))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 08:37
S58	420	S57 and ((silver or Ag) same (layer\$5 or coat\$5 or film\$2))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 08:38

S59	125	S58 and (refract\$7 same (index\$3 or indic\$3))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 08:38
S60	50	S59 and @PY<"2004"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 08:38
S61	1	"10562121"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 08:59
S62	57	(window adj glass) same (glaz\$4 same laminat\$3)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 11:31
S63	14	S62 and (electromagnetic)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 11:33

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